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# TRANSMITTAL FORM

(to be used for all correspondence after initial filing)

Total Number Of Pages In This Submission

4 pages

Application Number

10/618,155

Filing Date

July 11, 2003

First Named Inventor

Jaime Poris

Group Art Unit

2812

Examiner Name

Unknown

Attorney Docket No.

NAN068 US

## ENCLOSURES (check all that apply)

☐ Fee Transmittal Form

☐ Fee Attached

☐ Amendment / Reply

☐ After Final

☐ Affidavits/declarations

☐ Extension of Time Request

☐ Express Abandonment Request

☒ Information Disclosure Statement (2 pages)

☐ Certified Copy of Priority Document(s)

☐ Response to Missing Parts/  
Incomplete Application

☐ Response to Missing Parts  
under 37 CFR 1.52 or 1.53

☐ Assignment Papers  
(for an Application)

☐ Drawing(s)

☐ Licensing-related Papers

☐ Petition

☐ Petition to Convert to a  
Provisional Application

☐ Power of Attorney, Revocation of  
Previous Powers; And Statement  
Under 37 CFR 3.73(b)

☐ Terminal Disclaimer

☐ Request for Refund

☐ CD, Number of CD(s) \_\_\_\_\_

☐ After Allowance Communication to  
Group

☐ Appeal Communication to Board of  
Appeals and Interferences

☐ Appeal Communication to Group  
(Appeal Notice, Brief, Reply Brief)

☐ Proprietary Information

☐ Status Letter

☒ Other Enclosure(s) (please identify  
below):

- \* Return Receipt Postcard
- \* Form PTO-1449 (1 page)\*

Remarks

Please charge Deposit Account 50-2263 for any required fee.

## SIGNATURE OF APPLICANT, ATTORNEY OR AGENT

Firm  
or  
Individual Name

Michael J. Halbert (Reg. No. 40,633)  
Silicon Valley Patent Group LLP  
2350 Mission College Boulevard, Suite 360  
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Signature

Date

5-10-04

## CERTIFICATE OF MAILING BY "FIRST CLASS"

I hereby certify that this paper or fee is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on the below date.

Michael J. Halbert

May 10, 2004

Date

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventors: Jaime Poris  
Assignee: Nanometrics Incorporated.  
Title: Accurate Thickness Measurement of Thin Conductive Film  
Serial No.: 10/618,155 Filing Date: July 11, 2003  
Examiner: Unknown Group Art Unit: 2812  
Docket No.: NAN068 US Confirmation No: 4143

Santa Clara, California  
May 10, 2004

COMMISSIONER FOR PATENTS  
P.O. BOX 1450  
ALEXANDRIA, VA 22313-1450

**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT  
UNDER 37 CFR §1.97(b)**

Dear Sir:

Pursuant to 37 C.F.R. § 1.56, §1.97 and §1.98, the Applicants submit for consideration in the above-identified patent application the document listed on the accompanying Form PTO-1449. The Examiner is requested to make these documents of record.

This Information Disclosure Statement is submitted pursuant to 37 CFR §1.97(b) as it within three months of the filing date of a national application other than a continued prosecution application and/or before the mailing of a first Office Action on the merits. Accordingly, no fee is required.

Applicants would appreciate the Examiner initialing and returning the Form PTO-1449, indicating that the information has been considered and made of record herein.

The information contained in this Information Disclosure Statement is to the best of my knowledge and is not to be construed as a representation that: (i) a complete search has been made; (ii) additional information material to the

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examination of this application does not exist; (iii) the information, protocols, results and the like reported by third parties are accurate or enabling; or (iv) the above information constitutes prior art to the subject invention.

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Michael J. Halbert

Respectfully submitted,



Michael J. Halbert  
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Reg. No. 40,633

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# INFORMATION DISCLOSURE STATEMENT BY APPLICANT

Application No.:	10/618,155
Filing Date:	July 11, 2003
First Named Inventor:	Jaime Poris
Group Art Unit:	2812
Examiner Name:	Unknown
Confirmation No.:	
Attorney Docket No.:	NAN068 US

[illegible][illegible][illegible]

Date Considered:

\* Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication with applicant.